EV077332066

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

References -- See Attached Form PTO-1449

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. Section 1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Dated: 6-24-02 Attorney: \_\_\_

D. Brent Kenady

-Reg.-No.-40<del>,</del>045

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Application Serial No		
Filing Date	OIPE	
Inventor	/	: Richard Holscher et al.
Assianee		Micron Technology, Inc.
Group Art Unit	. \ o	1/56
Examiner	\Z	Unknown
Attorney's Docket No	PRADEMIN	
Title: Semiconductor Process	ing Methods	

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

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Respectfully submitted,

Dated: 4-23.00 Attorney:

Application Serial No		
Filing Date		June 19, 2001
Filing Date	JUN 2 DOC S	Richard Holscher et al.
Assignee	\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\\	Micron Technology, Inc.
Assignee	TRADEMINE.	
Examiner		Unknown
Attorney's Docket No		
Title: Semiconductor Processing M		

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Respectfully submitted,

Dated: 1-28-02 Attorney: DButter

	/PE A	
Application Serial No		
Filing Date		June 19, 2001
Inventor	· · · · · · · · · · · · · · · · · · ·	June 19, 2001 Richard Holscher et al.
Assignee	/ <del>تلام</del> ر	<pre>/Micron Technology, Inc.</pre>
Group Art Unit	TO TO A DEMINE	
Examiner	G INN	Unknown
Attorney's Docket No		MI22-1694
Title: Semiconductor Processing	Methods	

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Respectfully submitted,

Reg. No. 27,376

Application Serial No	OIPE	09/885 393
Filing Date	8	June 19 2001
Filing Date	HIN . 2 4 2002	Richard Holscher et al.
Assignee	٠٠ (چَا	Micron Technology, Inc.
Group Art Unit	· CAR TO LOT MILE	
Examiner	G THAUE	Unknown
Attorney's Docket No		MI22-1694
Title: Semiconductor Processing Metl	hods	

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References -- See Attached Form PTO-1449

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Respectfully submitted,

Dated: 8-21-01 Attorney: D. Brent Kenady

Reg. No. 40,045

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Application Serial No	1011 E	
Filing Date	/	June 19, 2001
Inventor	يبي . 2002 يايا يايا	Richard Holscher et al.
Assignee	\ <u>p.</u>	Micron Technology, Inc.
Group Art Unit	No.	
Group Art Unit	TRADEM	Unknown
Attorney's Docket No		
Title: Semiconductor Processing Meth	hods	

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

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Respectfully submitted,

Dated: 7-39-01 Attorney: DQu

EL46578049

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No	09/030.618
Priority Filing Date	/
Inventor	Richard Holscher et al
Assignee	Micron Technology, Inc.
<u>Priority</u> Group Art Unit	· · \& · · · · · · . & · · · · · · · · · · ·
Priority Examiner	K. Duda
Attorney's Docket No	MI22-1694
Title: Semiconductor Processing Methods	

## INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, copending application of the above-identified application. The above-identified application is a continuation of co-pending Application Serial No. 09/030,618, filed on February 25, 1998. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 6-19-01

Attorney: \_